



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Pei-Yang Yan

§

Art Unit: 1756

Serial No.: 10/633,211

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Examiner: Saleha R. Mohamedulla

Filed: August 1, 2003

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Docket: ITL.0956US
P15980

For: Proximity Correcting
Lithography Mask Blanks

§

Assignee: Intel Corporation

§

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 030705

Sir:

In response to the office action mailed March 10, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: May 16, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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